

Title (en)

SENSOR AND METHOD FOR PRODUCING A SENSOR

Title (de)

SENSOR UND VERFAHREN ZUR HERSTELLUNG EINES SENSORS

Title (fr)

DETECTEUR ET SON PROCEDE DE PRODUCTION

Publication

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Application

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Abstract (en)

[origin: WO03106955A1] The invention relates to a sensor, which is suitable for measuring high pressure and a method for producing said sensor. According to said method, a cavity (500) with a high aspect ratio is configured in a semiconductor material (51).

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G01L 9/00

IPC 8 full level

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